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Docket No. 0756-958

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on November 10, 1997.

*Cameron S. Gilligan*  
Cameron S. Gilligan

**RESPONSE UNDER 37 CFR 1.116 - EXPEDITED  
PROCEDURE - EXAMINING GROUP 2508**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of: )  
Shunpei YAMAZAKI et al. )  
Serial No. 08/183,800 ) Examiner S. Crane  
Filed: January 21, 1994 ) Art Unit: 2508  
For: SEMICONDUCTOR MATERIAL )  
AND METHOD FOR FORMING )  
THE SAME AND THIN FILM )  
TRANSISTOR ) November 10, 1997

**AMENDMENT AFTER FINAL**

Honorable Assistant Commissioner for Patents  
BOX AF  
Washington, D.C. 20231  
Sir:

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In response to the Final Office Action mailed June 10, 1997, please  
amend the above-identified application as follows.

11/17/1997 JARTIS 00000001 08183800  
01 FC:103 132.00 OP  
02 FC:116 400.00 OP

**IN THE CLAIMS:**

Please amend claims 23, 25, 27, 32-38 as follows: